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Date Submitted: <u>12-11-2007</u>		Application Number	10/759,592
		Filing Date	1/16/2004
		First Named Inventor	Jie Liu
		Art Unit	1775
		Examiner Name	Daniel H. Miller
(use as many sheets as necessary)			
Sheet	1	of	1
Attorney Docket Number <u>062987-0107</u>			

U.S. PATENT DOCUMENTS

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Examiner Initials	Cited Patent Number	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
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FOREIGN PATENT DOCUMENTS

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	B1	LIU et al., "Advances in CN _x Nanotube Growth," Mat. Res. Soc. Symp., Proc., 2003, 772:M2.5.1-M2.5.7.	
	B2	PURETZKY et al., "In situ measurements and modeling of carbon nanotube array growth kinetics during chemical vapor deposition," Appl. Phys., A, 2005, 81:223-240.	
	B3	TERRONES et al., "N-doping and coalescence of carbon nanotubes: synthesis and electronic properties," Appl. Phys. A, 2002, 74:355-361.	
	B4	YUN et al., "Growth Mechanisms of Long Aligned Multiwall Carbon Nanotube Arrays by Water-Assisted Chemical Vapor Deposition," J. Phys. Chem. B, 2006, 110:23920-23925.	

Examiner Signature	/Daniel Miller/	Date Considered	02/07/2008
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***EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. 1 Applicant's unique citation designation number (optional). 2 See *Kinds Codes of USPTO Patent Documents* at www.uspto.gov or MPEP 901.04, 3 Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3), 4 For Japanese patent documents, the indication of the year of the reign of the emperor must precede the serial number of the patent document. 5 Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. 6 Applicant is to place a check mark here if English language Translation is attached. This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time required or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, 1450 M St. NW, Washington, DC 20531-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.